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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Go MIYA et al.
Serial No.: 10/781,689
Filed: February 20, 2004
For: **A DIAGNOSIS METHOD FOR SEMICONDUCTOR
PROCESSING APPARATUS**
Group: 1763
Examiner: Parviz Hassanzadeh

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 12, 2004

Sir:

In response to the Office Action (Paper No. 06/2004) dated on June 15, 2004,
please amend the above-identified application as follows.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.